

03560.003451

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: D. J. Rutledge
Yoshikazu MIYAJIMA et al.)	
	:	Group Art Unit: 2851
Application No.: 10/820,120)	
	:	Confirmation No.: 8660
Filed: April 8, 2004)	
	:	February 12, 2008
For: STAGE APPARATUS, EXPOSURE SYSTEM)	
USING THE SAME, AND DEVICE	:	
MANUFACTURING METHOD)	

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated November 14, 2007, please amend the above-identified application as follows.